

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT						
NATURE OF CONVEYANCE:	ASSIGNMENT						
CONVEYING PARTY DATA							
<table border="1"> <thead> <tr> <th>Name</th> <th>Execution Date</th> </tr> </thead> <tbody> <tr> <td>FENGLIAN LI</td> <td>11/20/2013</td> </tr> <tr> <td>JINGHUA NI</td> <td>11/20/2013</td> </tr> </tbody> </table>		Name	Execution Date	FENGLIAN LI	11/20/2013	JINGHUA NI	11/20/2013
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FENGLIAN LI	11/20/2013						
JINGHUA NI	11/20/2013						
RECEIVING PARTY DATA							
Name:	SEMICONDUCTOR MANUFACTURING INTERNATIONAL (SHANGHAI) CORPORATION,						
Street Address:	18 ZHANGJIANG ROAD, PUDONG NEW AREA,						
City:	SHANGHAI						
State/Country:	CHINA						
Postal Code:	201203						
PROPERTY NUMBERS Total: 1							
<table border="1"> <thead> <tr> <th>Property Type</th> <th>Number</th> </tr> </thead> <tbody> <tr> <td>Application Number:</td> <td>14096286</td> </tr> </tbody> </table>		Property Type	Number	Application Number:	14096286		
Property Type	Number						
Application Number:	14096286						
CORRESPONDENCE DATA							
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ATTORNEY DOCKET NUMBER:	00158.0146.00US						
NAME OF SUBMITTER:	GRACE GAO						
Signature:	/Grace Gao/						

Date:

12/04/2013

Total Attachments: 2

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US Rights
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ASSIGNMENT

WHEREAS I/We, the below named inventor(s) (hereinafter referred to as Assignor(s)) have made an invention entitled:

MOS TRANSISTORS AND FABRICATION METHOD THEREOF

for which I/We executed an application for United States Letters Patent concurrently herewith or filed an application for United States Letters Patent on _____ (Application No. _____); and

WHEREAS, Semiconductor Manufacturing International (Shanghai) Corporation, a corporation of P. R. China whose post office address is 18 Zhangjiang Road, Pudong New Area, Shanghai, China 201203 (hereinafter referred to as Assignee), is desirous of securing the entire right, title, and interest in and to this invention in all countries throughout the world, and in and to the application for United States Letters Patent on this invention and the Letters Patent to be issued upon this application;

NOW THEREFORE, be it known that, for good and valuable consideration the receipt of which from Assignee is hereby acknowledged, I/We, as Assignor(s), have sold, assigned, transferred, and set over, and do hereby sell, assign, transfer, and set over unto the Assignee, its lawful successors and assigns, my/our entire right, title, and interest in and to this invention, provisional Application No. _____, filed _____ (if any), and this application, and all divisions, and continuations thereof, and all Letters Patent of the United States which may be granted thereon, and all reissues thereof, and all rights to claim priority on the basis of the above provisional application (if any), as well as all rights to claim priority on the basis of this application, and all applications for Letters Patent which may hereafter be filed for this invention in any foreign country and all Letters Patent which may be granted on this invention in any foreign country, and all extensions, renewals, and reissues thereof; and I/We hereby authorize and request the Commissioner of Patents and Trademarks of the United States and any official of any foreign country whose duty it is to issue patents on applications as described above, to issue all Letters Patent for this invention to Assignee, its successors and assigns, in accordance with the terms of this Assignment;

AND, I/WE HEREBY covenant that I/We have the full right to convey the interest assigned by this Assignment, and I/We have not executed and will not execute any agreement in conflict with this Assignment;

AND, I/WE HEREBY further covenant and agree that I/We will, without further consideration, communicate with Assignee, its successors and assigns, any facts known to me/us respecting this invention, and testify in any legal proceeding, sign all lawful papers when called upon to do so, execute and deliver any and all papers that may be necessary or desirable to perfect the title to this invention in said Assignee, its successors or assigns, execute all divisional, continuation, and reissue applications, make all rightful oaths and generally do everything possible to aid Assignee, its successors and assigns, to obtain and enforce proper patent protection for this invention in the United States and any foreign country, it being understood that any expense incident to the execution of such papers shall be borne by the Assignee, its successors and assigns.

AND, I/WE HEREBY authorize and request the attorneys I/we have empowered in the Declaration and Power of Attorney in this application, to insert here in parentheses (Application No. _____, filed _____) the filing date and application number of said application when known.

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IN TESTIMONY WHEREOF, I/We have hereunto set our hands.

Inventor 1:

Name: FENGLIAN LI

Address: 18 Zhangjiang Road, Pudong New Area
Shanghai, China 201203

Signature: Fenglian Li

Date: 2013. 11. 20

Inventor 2:

Name: JINGHUA NI

Address: 18 Zhangjiang Road, Pudong New Area
Shanghai, China 201203

Signature: Jinghua Ni

Date: 2013. 11. 20